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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2812
Examiner: Stanetta D. Isaac

In Re PATENT APPLICATION of:

Applicant(s): Jun KANAMORI

Serial No.: 10/634,851

Filing Date: August 6, 2003

For: SEMICONDUCTOR DEVICE
FABRICATION METHOD USING
OXYGEN ION IMPLANTATION

Atty. Dkt.: MAE 292

REQUEST FOR
RECONSIDERATION

August 11, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Please Enter
SDI 8/24/05

Sir:

Reconsideration of the final rejections presented in the Examiner's Action
mailed on May 25, 2005, is requested for the following reasons: